

Form PTO 1449

**INFORMATION DISCLOSURE CITATION
IN AN APPLICATION**

(Use several sheets if necessary)

Docket Number (Optional) **RADNT-031A**Application Number **10/015/220**Applicant **Michael W. Dae, et al**Filing Date **October 26, 2001**

Group Art Unit

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	RULING DATE IF APPROPRIATE
<i>MJA</i>	3,425,419	Feb. 4, 1969	A.A. Dato			
	4,111,209	Sep. 5, 1978	Wolvek et al.			
	4,762,130	Aug. 9, 1988	Fogarty et al.			
	5,151,100	Sep. 29, 1992	Abele et al.			
	5,211,631	May 18, 1993	Sheaff			
	5,486,208	Jan. 23, 1996	Ginsberg			
	5,624,392	Apr. 29, 1997	Saab			
	5,716,386	Feb. 10, 1998	Ward et al.			
	5,837,003	Nov. 17, 1998	Ginsberg			
	5,957,963	Sep. 28, 1999	Dobak, III			
	6,042,559	Mar. 28, 2000	Dobak, III			
	6,051,019	Apr. 18, 2000	Dobak, III			
	6,096,068	Aug. 1, 2000	Dobak, III et al.			
	6,126,684	Oct. 3, 2000	Gobin et al.			
	6,146,411	Nov. 14, 2000	Noda et al.			
	6,149,670	Nov. 21, 2000	Worthen et al.			
	6,224,624 B1	May 1, 2001	Lasheras et al.			
	6,231,594 B1	May 15, 2001	Dae			
	6,238,428	May 29, 2001	Werneth et al.			
<i>MJA</i>	6,245,095 B1	Jun. 12, 2001	Dobak, III et al.			

FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
					YES NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

Michael J. Hayer

DATE CONSIDERED

11/17/03

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FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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Applicant **Michael W. Dae, et al**

JUL 28 2003

IN AN APPLICATION

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